

Docket No.: 21806-00157-US  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Robert T. Froebel et al.

Application No.: 10/707,864

Confirmation No.: 1863

Filed: January 19, 2004

Art Unit: 2877

For: ALIGNMENT MARK SYSTEM AND  
METHOD TO IMPROVE WAFER  
ALIGNMENT SEARCH RANGE

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Examiner: I. O. Akanbi

**AMENDMENT FILED WITH REQUEST FOR CONTINUED EXAMINATION**

**MS RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

This is in response to the Final Rejection mailed February 8, 2007 in the above-captioned case.

Amendments to the Claims are reflected in the Listing of Claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.